

01/24/02
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Docket No.: M-12467 US

Box Patent Application
Commissioner For Patents
Washington, D. C. 20231

January 24, 2002

Enclosed herewith for filing is a patent application, as follows:

Inventor: Renken, Wayne

Title: PROCESS CONDITION SENSING WAFER AND DATA ANALYSIS SYSTEM

X Return Receipt Postcard
X This Transmittal Letter (in duplicate)
13 page(s) Specification (not including claims)
7 page(s) Claims
1 page Abstract
10 Sheet(s) of Drawings
1 page NonPublication Request

☒ Applicant asserts entitlement to small entity status for the attached patent application

CLAIMS AS FILED (fees computed under 37 CFR §1.9(f))

For	Number Filed		Number Extra		Rate		Basic Fee
Total Claims	45	-20 =	25	x	\$ 9.00	=	\$ 225.00
Independent Claims	3	-3 =	0	x	\$42.00	=	\$ 0.00
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application							\$
<input type="checkbox"/> Fee for Request for Extension of Time							\$

Please make the following charges to Deposit Account 19-2386:

- ☒ Total fee for filing the patent application in the amount of \$ 595.00
☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 19-2386.

EXPRESS MAIL LABEL NO:
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Respectfully submitted,

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